

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Masatoshi AKAGAWA, et al.

Serial No. 10/790,872

Group Art Unit: 2853

Confirmation No. 3133

Filed: March 3, 2004

Examiner: NGUYEN, LAM S

For: PATTERN DRAWING APPARATUS AND PATTERN DRAWING METHOD FOR FORMING PATTERNS, THAT HAVE MIRROR IMAGE RELATIONSHIP TO EACH OTHER WITH RESPECT TO A SUBSTRATE, ON BOTH SIDES OF THE SUBSTRATE, AND TEST APPARATUS FOR USE IN THE PATTERN DRAWING APPARATUS

**AMENDMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Non-Final Office Action mailed March 22, 2007, and having a period for response set to expire on June 22, 2007.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.